EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S2	12	US-5675158-\$.DID. OR US-5880495-\$.DID. OR US-5892253-\$.DID. OR US-5881184-\$.DID. OR US-6107655-\$.DID. OR US-5245201-\$.DID.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/06 15:55
S3	2	("6661459").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/06 16:07
S4	2	"59198756"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/06 16:08
S5	2	"8335690"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/06 16:09
S6	12	"0738010"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/06 16:10
S7	6	"0809299"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/06 16:12
S21	6	("5065206" "5191398" "5625210" "5631704" "5698874" "5739562").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2006/11/07 09:22
S20	2	("5892253").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/07 09:22
S32	943	348/308.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/08 08:26

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C24	1005	257/200 202 cela	LIC DCDUD	OD	011	2006/44/08 42 55
S34	1885	257/290-292.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/08 10:22
S33	967	257/292.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/08 10:22
S39	293	S38 and imag\$3 near2 sens\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/08 10:23
S38	449	S36 and S37	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/08 10:23
S37	129872	implant\$5 with ion	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/08 10:23
S36	1036	S34 and S35	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/08 10:23
S35	348961	semiconductor same type	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/08 10:23
S31	2	("6023081").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/08 11:04
S30	2	("5892253").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/11/08 11:04
L1	3868	348/294-324.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/08 13:37

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L3	211	2 and (dop\$3 or ion) with implant\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/08 13:38
L2	1098	1 and semiconductor same type	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/11/08 13:38
L7	83	6 and ion with implant\$5	US-PGPUB; USPAT	OR	ON	2006/11/08 14:24
L6	265	(Toru near2 Koizumi or Shigetoshi near2 Sugawa or Isamu near2 Ueno or Tetsunobu near2 Koichi or Katsuhito near2 Sakurai or Hiroki near2 Hiyama).in.	US-PGPUB; USPAT	OR .	ON	2006/11/08 14:24